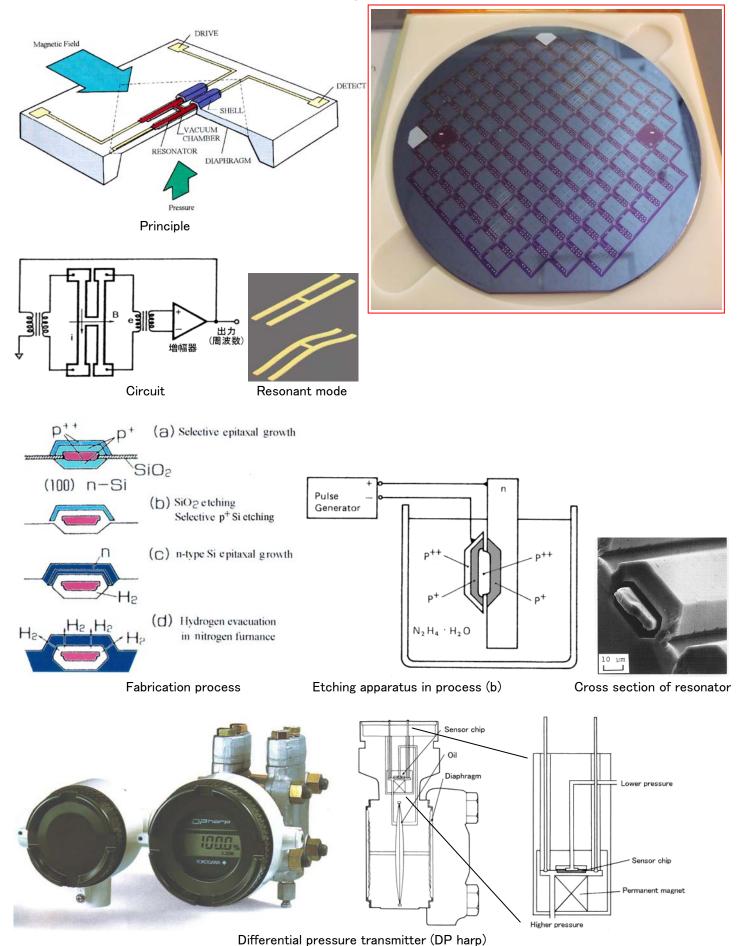
## Resonant Pressure Sensor (Yokogawa Electric)



Reference: K.Ikeda, H.Kuwayama, T.Kobayashi, T.Watanabe, T.Nishikawa and T.Yoshida, Silicon Pressure Sensor with Resonant Strain Gages Built into Diaphragm, Tech. Digests of the 7th Sensor Symposium (1988) pp.55–58